

13049 U.S. PTO



121503

Docket No. 7471/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

121503 U.S. PTO
10/736242

Re: Inventors: Robert Tolles, David P. Alvarez and Jianshe Tang
Title: MEGASONIC WAFER CLEANING TANK WITH REFLECTOR FOR IMPROVED WAFER EDGE CLEANING

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 14 pages.
☒ Drawings totaling three pages, ☒ Formal ☐ Informal.
☒ Return Postcards

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	18	- 20 =	-0-	X \$18.00	\$0.00
Independent Claims	4	- 3 =	1	X \$86.00	\$86.00
Basic Filing Fee				\$770.00	\$770.00
TOTAL FEES					\$856.00

☐ The Commissioner is hereby authorized to charge \$856.00 to Deposit Account No. 04-1696.

☐ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-1696. A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to:
**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Express Mail Receipt No. EL975550037USDate of Deposit: December 15, 2003

Signature:

Respectfully submitted,

Brian M. Dugan
Registration No. 41,720
(914) 332-9081